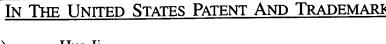


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant(s):

Hua Ji

Assignee:

Mosel Vitelic, Inc.

Title:

HDP CVD Process For Void-Free Gap Fill Of A High Aspect Ratio

Trench

10/080,468

Filing Date:

February 22, 2002

Examiner:

Anh D. Mai

Group Art Unit:

2814

Docket No.:

M-12589US

Irvine, California August 20, 2002

BOX AMENDMENT COMMISSIONER FOR PATENTS Washington, D. C. 20231

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated May 20, 2002, Applicant submits the following amendments and remarks.

IN THE DRAWINGS

FIGS. 1-5 have been designated with a legend indicating "Prior Art" as requested and submitted on a separate paper showing the proposed changes in red. Accordingly, Applicant respectfully requests that the objection to the drawings be withdrawn.

IN THE SPECIFICATION

In accordance with 37 C.F.R. 1.121(c)(2)(ii), Attachment A provides marked up versions of the replacement paragraphs illustrating the newly introduced changes in the specification.

Please replace the paragraph on page 8, line 3 through line 22, with the following replacement paragraph: 00000001 502257 10080468

08/29/2002 WABDELR

01 FC:103

18.00 CH

-1-

Serial No. 10/080,468

LAW OFFICES OF IACPHERSON KWOK CHEN & HEID 113

02 MICHELSON DRIVE SUITE 210 IRVINE, CA 92612 (949) 752-7040 FAX (949) 752-7049